

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Lucius M. Sherwin

Docket No.: TI-30661

Serial No: TBD

Examiner: TBD

Filed: 08/02/01

Art Unit: TBD

For: A PARTICLE DETECTION AND REMOVAL APPARATUS FOR USE ON  
WAFER FABRICATION EQUIPMENT TO LOWER TOOL RELATED  
DEFECTS FROM PARTICLE CONTAMINATION

PRELIMINARY AMENDMENT

August 2, 2001

Assistant Commissioner for Patents

Washington, DC 20231

Dear Sir:

Please amend the above referenced application as follows:

In the Specification:

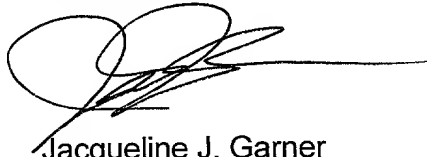
Page 1, before line 1, insert --This application claims priority under 35 USC §  
119(e)(1) of provisional application numbers **60/224,434** filed **08/10/00**.--

## REMARKS

Entry of the foregoing amendment prior to examination is respectfully requested.

If the Examiner has any questions or other correspondence regarding this application, Applicant requests that the Examiner contact Applicant's attorney at the below listed telephone number and address.

Respectfully submitted,



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